



PATENT APPLICATION

416
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takashi AOKI et al.

Group Art Unit: 2872

Application No.: 09/913,328

Filed: October 15, 2001

Docket No.: 110356

For: EXPOSURE METHOD AND APPARATUS

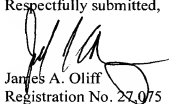
INFORMATION DISCLOSURE STATEMENTDirector of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The reference was cited in a counterpart foreign application. An English language version of the International Preliminary Examination Report is attached for the Examiner's information.
- ☒ 3. Reference JP 9-162117 A, which is cited in the International Preliminary Examination Report was submitted with an Information Disclosure Statement filed on October 15, 2001.

Respectfully submitted,


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Date: February 25, 2002

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